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Substitute for form 1449A/PTO <b>APR 20 2005</b> <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> (Use as many sheets as necessary)		Application Number	10/659,031		
		Filing Date	September 9, 2003		
		First Named Inventor:	Yakov Roizin		
		Examiner name: Andy Huynh	GROUP: 2818		
Sheet	1	of	1	Attorney Docket Number	TSL-125

## U.S. PATENT DOCUMENTS

Examiner Initials*	Cited No. <sup>1</sup>	Document Number Number - Kind Code <sup>2(f/known)</sup>	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Passages or Figures Appear
ah	A01	US-6,256,231 B1	07-03-2001	Yoav Lavil	—
ah	A02	US-6,181,597 B1	01-30-2001	Ishai Nachumovsky	—
ah	A03	US-6,081,456	06-27-2000	Oleg Dadashev	—
		US-			
		US-			

## FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document Cntry Code <sup>3</sup> Number <sup>4</sup> Kind Code <sup>5(f/known)</sup>	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Passages or Figures Appear	T <sup>6</sup>
ah	A04	JP 2001-284563	12-10-2001	Sony Corp.	—	

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

ah	"Mechanism of Charge Induced Plasma Damage to EPROM Cells During Fabrication of Integrated Circuits", by C.K. Barlingay, R. Yach & W. Likaszek; 7 <sup>th</sup> Int'l. Symposium on Plasma- and Process-Induced Damage, June 2002, Hawaii
ah	"Avoiding Plasma Induced Damage To Gate Oxide With Conductive Top Film (CTF) on PECVD Contact Etch Stop Layer", by S. Song et al., 2002 Symposium On VLSI Technology Digest of Technical Papers

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next communication to applicant. 1 Applicant's unique citation designation number (optional). 2 See Kinds Codes of USPTO Patent Documents at [www.uspto.gov](http://www.uspto.gov) or MPEP 901.04. 3 Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). 4 For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. 5 Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. 6 Applicant is to place a check mark here if English language Translation is attached.

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